

Our ref.: KON-2020

Client's ref.: P6636-001-0000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Hiromoto, II, :  
et al

Art Unit: 1792

Appln. No.: 10/544,084 :

Examiner: David P.  
TUROCY

Filed: July 28, 2005 :

For: FILM FORMING METHOD AND :  
SUBSTRATE HAVING A FILM :  
FORMED BY THE METHOD :

Dated: September 11, 2009

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Confirmation #9413

**RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE**

I hereby certify that this correspondence is being EFS-Web or facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 11, 2009.

LUCAS & MERCANTI, LLP

BY: Donald C Lucas  
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S i r:

This is in response to an Office Action dated June 16, 2009 in this Application. Attached hereto are Claim Amendments, a Certified English Translation of the Japanese Priority Document JP 2003-197799 and Remarks, each starting on a separate page.